

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hiroshi MORIOKA et al.**

Art Unit: **1795**

Application Number: **10/692,722**

Examiner: **Daborah Chacko-Davis**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND
SEMICONDUCTOR DEVICE MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 17, 2008

Sir:

This paper is filed in response to the Office Action dated September 17, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.